



Attorney Docket SEL 171

AF #  
2005

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of:

Masaya Kadono et al.

Serial No.: 09/535,233

Filed: March 24, 2000

For: A Method Of Manufacturing A  
Semiconductor Device

Art Unit: 2823

Examiner: W. Coleman

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:  
Commissioner for Patents,  
P.O. Box 1450, Alexandria, VA 22313-1450 on

September 9, 2005

(Date of Deposit)

Shannon Wallace

Name of applicant, assignee, or Registered Rep.

Shannon Wallace 9/9/05

Date

Signature

Sir:

In response to the Final Rejection of June 9, 2005, please enter the following amendment in

the above-identified application:

9/12/05

V 3 4  
1 10 with draw  
V 36 notes